Electronic Pate	ent App	lication Fee	Transm	ittal			
Application Number:	105	10524610					
Filing Date:	11-	11-Aug-2005					
Title of Invention:	ME	LAYER SYSTEM COMPRISING A SILICON LAYER AND A PASSIVATION LAYER, METHOD FOR PRODUCTION A PASSIVATION LAYER ON A SILICON LAYER AND THE USE OF SAID SYSTEM AND METHOD					
First Named Inventor/Applicant Name:	Fra	Franz Laermer					
Filer:	Ge	Gerard A. Messina/Katy Chan-Parsons					
Attorney Docket Number:	101	10191/4116					
Filed as Large Entity							
U.S. National Stage under 35 USC 371 F	iling Fee	5					
Description		Fee Code	Quantity	Amount	Sub-Total ir USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Utility Appl issue fee		1501	1	1510	1510		

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
	Total in USD (\$)			1810